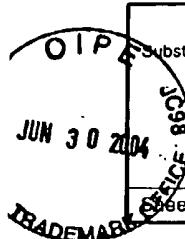


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Substitute for form 1449A/PTO				<b>Complete If Known</b>	
				Application Number	09/976,001
				Filing Date	October 15, 2001
				First Named Inventor	T. UCHIDA et al.
				Art Unit	1765
				Examiner Name	Lynette T. Umez Eronini
				Attorney Docket Number	566.39787CX1

U.S. PATENT DOCUMENTS					Class / Subclass	
Examiner Initials*	Cite No. <sup>1</sup>	Document Number		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code <sup>3</sup> (if known)				
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Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document		Name of Patentee or Applicant of Cited Document	
		Country Code <sup>3</sup> -Number <sup>4</sup> -Kind Code <sup>5</sup> (if known)			
SJT/ME		JP 08-083780	03-26-1996	TOSHIDA CORP	ABS
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SJT/ME		WO 00/00561	01-06-2000	CABOT CORPORATION	

OTHER PRIOR ART—NON PATENT LITERATURE DOCUMENTS				
Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher city and/or country where published		
SJT/ME		Y. HAYASHI et al., "A New Abrasive-Free, Chemical-Mechanical-Polishing for Aluminum Metallization of ULSI Devices", International Electron Devices Meeting Technical Digest, 1992, pp. 976-978		
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Examiner Signature	Lynette T. Umez-Eronini	Date Considered	7/21/2004
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use several sheets if necessary)			APPLICANT T. Uchida, et al.		
			FILING DATE October 15, 2001	GROUP 1765	



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## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

AM	
Examiner <i>Lynette T. Umeg-Eunice</i>	Date Considered <i>7/26/2004</i>

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